

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): Shinji Omori, et al. ATTY. DOCKET NO.: 09792909-6248  
 SERIAL NO.: Unknown GROUP ART UNIT: Unknown  
 DATE FILED: May 11, 2005 EXAMINER: Unknown  
 INVENTION: "EXPOSURE APPARATUS, EXPOSURE METHOD AND  
 SEMICONDUCTOR DEVICE MANUFACTURING METHOD"

Mail Stop: PCT  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. SUBMITTED US PATENT REFERENCES

	<u>Number</u>	<u>Inventor(s)</u>	<u>Date of Publication</u>
AA	5,831,272	Utsumi	November 3, 1998

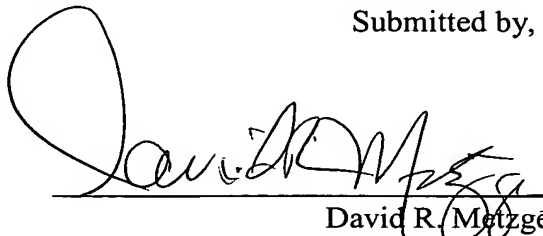
II. SUBMITTED FOREIGN PATENT REFERENCES

	<u>Number</u>	<u>Country</u>	<u>Date of Publication</u>
AH	WO 03/083913	World	October 9, 2003
AI	JP2003-297716 (Japanese counterpart to WO 03/083913)	Japan	October 17, 2003
AJ	JP2002-270496	Japan	September 20, 2002
AK	JP06-018220	Japan	January 25, 1994
AL	JP08-203817	Japan	August 9, 1996
AM	JP11-135423 (Japanese counterpart to US 5,831,272)	Japan	May 21, 1999
AN	JP2003-318084	Japan	November 7, 2003

III. OTHER ITEMS OF INFORMATIONIV. EXPLANATION OF RELEVANCE

The above-identified references were cited in the International Search Report of March 2, 2004, in counterpart PCT/JP03/14460. Copies of the International Search Report and all references are submitted herewith.

Submitted by,



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 INFORMATION DISCLOSURE STATEMENT  
 IN A PATENT  
 (use several sheets if necessary)

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Serial No.

Applicants:  
 Shinji Omori, et al.

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 May 11, 2005

Group Art Unit

### U.S. PATENT DOCUMENTS

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
	AA	5,831,272	11-3-98	Utsumi			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

### FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AH	WO 03/083913	10-9-03	World				
	AI	JP2003-297716	10-17-03	Japan			Abstract	
	AJ	JP2002-270496	9-20-02	Japan			Abstract	
	AK	JP06-18220	1-25-94	Japan			Abstract	
	AL	JP08-203817	8-9-96	Japan			Abstract	
	AM	JP11-135423	5-21-99	Japan				
	AN	JP2003-318084	11-7-03	Japan			Abstract	
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	AR							
	AS							
	AT							

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AU	
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	AY	
	AZ	

Examiner

Date Considered

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.